



Attorney's Docket No.: 10417-039001 / F51-125462M/HW

AF/2811  
H11C NE  
OKON  
3/18/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Toshimitsu Taniguchi et al.  
Serial No. : 09/652,044  
Filed : August 31, 2000  
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING  
THEREOF

Art Unit : 2811  
Examiner : Samuel A. Gebremariam

**BOX AF**

Commissioner for Patents  
Washington, D.C. 20231

AMENDMENT IN RESPONSE TO OFFICE ACTION DATED DECEMBER 2, 2002

In response to the action mailed December 2, 2002, please amend the application as follows:

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MAR 11 2003

TC 2800 MAIL ROOM

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

MARCH 3, 2003

Date of Deposit

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Signature

PATRICIA A. SUCHANECK

Typed or Printed Name of Person Signing Certificate